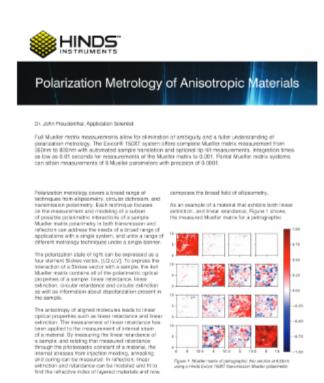


WHITE PAPERS & APPLICATION NOTES



Polarization Metrology of Anisotropic Materials

Full Mueller matrix measurements allow for elimination of ambiguity and a fuller understanding of polarization metrology. The Exicor® 150XT system offers complete Mueller matrix measurement from 350 nm to 800 nm with automated sample translation and optional tip-tilt measurements. Integration times as low as 0.01 seconds for measurements of the Mueller matrix to 0.001. Partial Mueller matrix systems can attain measurements of 8 Mueller parameters with precision of 0.0001.

DOWNLOAD WHITE PAPER



Visit Photonics Media to download other white papers and learn more about the latest developments in lasers, imaging, optics, biophotonics, machine vision, spectroscopy, microscopy, photovoltaics and more.

www.photonics.com/WhitePapers.aspx

We respect your time and privacy. You are receiving this email because you are a Photonics Spectra magazine subscriber. You may use the links below to manage your subscriptions or contact us.

Questions: info@photonics.com

Unsubscribe | Subscribe | Subscriptions | Privacy Policy | Terms and Conditions of Use

Photonics Media, 100 West St., PO Box 4949, Pittsfield, MA 01202-4949 © 1996 - 2021 Laurin Publishing. All rights reserved. Photonics.com is Registered with the U.S. Patent & Trademark Office. Reproduction in whole or in part without permission is prohibited.



